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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/836,065	04/16/2001	Janevoot Naksrikram	P1310	5713

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EXAMINER

CHAUDRY, MUJTABA M

ART UNIT	PAPER NUMBER
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2133

DATE MAILED: 12/01/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

Office Action Summary

Application No.

09/836,065

Applicant(s)

NAKSRIKRAM ET AL.

Examiner

Mujtaba K Chaudry

Art Unit

2133

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

- 1) ☒ Responsive to communication(s) filed on 06 August 2004.
- 2a) ☒ This action is **FINAL**. 2b) ☐ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

- 4) ☒ Claim(s) 1-18 is/are pending in the application.
- 4a) Of the above claim(s) _____ is/are withdrawn from consideration.
- 5) ☐ Claim(s) _____ is/are allowed.
- 6) ☒ Claim(s) 1-18 is/are rejected.
- 7) ☐ Claim(s) _____ is/are objected to.
- 8) ☐ Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☐ The drawing(s) filed on _____ is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
- 11) ☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

Priority under 35 U.S.C. § 119

- 12) ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
- a) ☐ All b) ☐ Some * c) ☐ None of:
- ☐ Certified copies of the priority documents have been received.
 - ☐ Certified copies of the priority documents have been received in Application No. _____.
 - ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

* See the attached detailed Office action for a list of the certified copies not received.

Attachment(s)

- | | |
|---|---|
| 1) <input type="checkbox"/> Notice of References Cited (PTO-892) | 4) <input type="checkbox"/> Interview Summary (PTO-413) |
| 2) <input type="checkbox"/> Notice of Draftsperson's Patent Drawing Review (PTO-948) | Paper No(s)/Mail Date. _____ |
| 3) <input type="checkbox"/> Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) | 5) <input type="checkbox"/> Notice of Informal Patent Application (PTO-152) |
| Paper No(s)/Mail Date _____ | 6) <input type="checkbox"/> Other: _____ |

DETAILED ACTION

Drawings

The insertion a "Prior Art" label to Figure 1 is accepted. However, this application, filed under former 37 CFR 1.60, lacks formal drawings. The informal drawings filed in this application are acceptable for examination purposes. New corrected drawings are required. Applicant is advised to employ the services of a competent patent draftsman outside the Office, as the U.S. Patent and Trademark Office no longer prepares new drawings. The corrected drawings are required in reply to the Office action to avoid abandonment of the application. The requirement for corrected drawings will not be held in abeyance.

Specification

The corrected or substitute specification were received on August 06, 2004. The specification is accepted.

Response to Amendment

Applicant's arguments/amendments with respect to amended claims 1-3, 5, 8, 12, 14 and 17 and original claims 4, 6, 7, 9, 11, 13, 15, 16 and 18 filed August 06, 2004 have been fully considered but are not persuasive. The Examiner would like to point out that this action is made final (See MPEP 706.07a).

Applicant contends, "...the prior arts of record (Noguchi and Kobayashi) do not teach a method for testing a semiconductor device having a first sector of a first sector type memory and

Art Unit: 2133

a second sector of a second sector type memory size.” The Examiner respectfully disagrees.

Noguchi teaches (col. 7 and Figure 14) a flow chart showing the erasing operation of this nonvolatile semiconductor memory device. First, at the stage of initializing, a program high voltage V_{pp} is applied to the instruction port controller 2 to render the instruction port controller 2 operative (a step S2). Then, specific data (00H) is programmed for all bytes, a step S4. This data programming is made in order to bring each memory cell into a write state and set the threshold voltage of each memory cell to be substantially equal. In addition, each counter is preset to a predetermined initial value (a step S6). This counter includes a counter for counting the number of time CUMTEW of the increase of an erase pulse width TEW, and a counter for counting the number of times PLSCNT by which erase pulses are generated. An address is set to 0. Then, an erase setup instruction is written into the instruction port controller 2 (the status register 235 and the instruction register 237) (a step S8), and an erase instruction is subsequently written into the instruction port controller 2 (a step S10). An erasing with respect to all the memory cells is executed in accordance with the writing of the erase instruction (a step S12). After a predetermined time period has passed, it is determined that the erasing of the memory cells is completed, and an erase verify instruction is written into the instruction port controller 2 (the status register 235 and the instruction register 237) (a step S14). In accordance with this erase verify instruction, an erase verify voltage is generated from the erase/program verification generator 9 and then transmitted via the X decoder 12 onto a selected word line in the memory cell array (a step S16). When a predetermined time period has passed (time T2), data reading is carried out (a step S18). If the read data is an erased data, then the data is "1". If the read data is an unerased data, then the data is "0". A determination is made as to whether this

Art Unit: 2133

data is in the erased state or not in accordance with its value (a step S20). If the data indicates the unerased state, then an erase pulse width to be applied to erase the data is incremented by a predetermined value, and this incremented erase pulse width information is stored in the TEW counter (a step S22). A determination is first made as to whether the erase pulse width stored in the TEW counter reaches a maximum limit value, and subsequently, a determination is made as to whether the number by which the erase pulses are applied reaches a predetermined value (64 times) (a step S24). When the erase pulse application number PLSCNT reaches the predetermined value (64 times), it is determined that no erasing is allowed for that memory cell any more, and an erase error is stored (a step S26). When the erase pulse application number PLSCNT does not reach the predetermined value in the step S24, the processing returns to the step S8, in which the writing and erasing operation by the erase setup instruction and the erase instruction is carried out. The Examiner would like to point out that Noguchi teaches to test a Flash memory which is also a non-volatile memory. By definition, a Flash memory is *an erasable programmable read-only memory in which clearing can be performed only on block or the entire array*. Therefore, Noguchi teaches a method for testing a semiconductor device having a first sector of a first sector type memory and a second sector of a second sector type memory size as stated in the present application.

Claim Rejections - 35 USC § 103

The factual inquiries set forth in *Graham v. John Deere Co.*, 383 U.S. 1, 148 USPQ 459 (1966), that are applied for establishing a background for determining obviousness under 35 U.S.C. 103(a) are summarized as follows:

Art Unit: 2133

1. Determining the scope and contents of the prior art.
2. Ascertaining the differences between the prior art and the claims at issue.
3. Resolving the level of ordinary skill in the pertinent art.
4. Considering objective evidence present in the application indicating obviousness or nonobviousness.

Claims 1-18 are rejected under 35 U.S.C. 103(a) as being unpatentable over Noguchi (USPN 5343434) further in view of Kobayashi et al. (USPN 5646948). From previous office action:

As per claims 1 and 10, Noguchi substantially teaches (title and abstract) a method and apparatus for performing erase testing on a semiconductor device. Noguchi teaches a memory device in a bare chip state which is determined as fail by over erasing during a test at a wafer level, information indicating the presence of an over-erased memory cell is stored in a nonvolatile and readable manner into an identification memory circuit, and then memory cells in a memory cell array are restored to an erase state of an electrically neutral state by irradiation with an energy beam such as ultraviolet rays. A chip erased by the energy beam such as ultraviolet rays is assembled as an OTPROM (one-time programmable read only memory) and tested. At that time, a writing/erasing control circuit for controlling data writing into and data erasing in the memory cells is brought into an operation-inhibited state in accordance with the information stored in the memory circuit. It is possible to reduce the rate at which fail products are produced by use of a flash memory which is determined as fail because of the presence of an over-erased memory cell as a one-time programmable memory device. Furthermore, Noguchi teaches (Figure 14) the erasing operation of a nonvolatile semiconductor memory device. First, at the stage of initializing, a program high voltage V_{pp} is applied to the instruction port controller 2 to render the instruction port controller 2 operative (a step S2). Then, specific data (00H) is programmed for all bytes (data input/output is carried out in the units of byte and

Art Unit: 2133

erasing is carried out also in the units of byte) (a step S4). This data programming is made in order to bring each memory cell into a write state and set the threshold voltage of each memory cell to be substantially equal. The Examiner would like to point out that this step is analogous to establishing a first test limit as stated in the present application. In addition, each counter is preset to a predetermined initial value (a step S6). This counter includes a counter for counting the number of time CUMTEW of the increase of an erase pulse width TEW, and a counter for counting the number of times PLSCNT by which erase pulses are generated. An address is set to 0. Then, an erase setup instruction is written into the instruction port controller 2 (the status register 235 and the instruction register 237) (a step S8), and an erase instruction is subsequently written into the instruction port controller 2 (a step S10). An erasing with respect to all the memory cells is executed in accordance with the writing of the erase instruction (a step S12). After a predetermined time period has passed, it is determined that the erasing of the memory cells is completed, and an erase verify instruction is written into the instruction port controller 2 (the status register 235 and the instruction register 237) (a step S14). In accordance with this erase verify instruction, an erase verify voltage is generated from the erase/program verification generator 9 and then transmitted via the X decoder 12 onto a selected word line in the memory cell array (a step S16). When a predetermined time period has passed (time T2), data reading is carried out (a step S18). If the read data is an erased data, then the data is "1". If the read data is an unerased data, then the data is "0". A determination is made as to whether this data is in the erased state or not in accordance with its value (a step S20). If the data indicates the unerased state, then an erase pulse width to be applied to erase the data is incremented by a predetermined value, and this incremented erase pulse width information is stored in the TEW counter (a

step S22). A determination is first made as to whether the erase pulse width stored in the TEW counter reaches a maximum limit value, and subsequently, a determination is made as to whether the number by which the erase pulses are applied reaches a predetermined value (64 times) (a step S24). When the erase pulse application number PLSCNT reaches the predetermined value (64 times), it is determined that no erasing is allowed for that memory cell any more, and an erase error is stored (a step S26). When the erase pulse application number PLSCNT does not reach the predetermined value in the step S24, the processing returns to the step S8, in which the writing and erasing operation by the erase setup instruction and the erase instruction is carried out. Noguchi does not explicitly teach to have a first sector of a first sector type and a second sector with a second sector type as stated in the present application. However, Kobayashi et al. (herein after: Kobayashi), in an analogous art, substantially teaches (title and abstract) a method and apparatus for testing a plurality of semiconductor memories in parallel. Kobayashi teaches a test data pattern, an address pattern, and a control signal are supplied from a pattern generator to a test memory. Data read from the test memory is compared with expected data by an XOR gate. When they match, a compared result that represents pass is output. When they mismatch, a compared result that represents fail is output. A match signal WC detected by the XOR gate is held in a register. The register outputs an inhibition signal to an inhibition gate of the test memory. Thus, a write enable signal WE is inhibited from being supplied to the test memory. In addition, the inhibition signal is supplied to a compared result inhibition gate. The compared result inhibition gate causes the compared result to be passed and prevents the test memory from being excessively written. Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to incorporate the

Art Unit: 2133

multiple memories of Kobayashi with the testing apparatus of Noguchi. This modification would have been obvious to one of ordinary skill in the art because one of ordinary skill in the art would have recognized that by applying the testing routine taught by Noguchi with multiple memory types would reduce overall testing time.

As per claims 2-6 and 11-15, Noguchi substantially teaches, in view of above rejections, (Figure 1) a block diagram showing an overall structure of a nonvolatile semiconductor memory device according to one embodiment. FIG. 1 shows a structure of a flash memory in which all memory cells in a memory cell array 13 are brought into an erase state at the same time. This structure corresponds to the structure of the conventional nonvolatile semiconductor memory device shown in FIG. 12. The structure of this memory device is applicable not only to the flash memory in which all memory cells of the memory cell array 13 are erased at the same time but also to a nonvolatile semiconductor memory device of the type in which erasing is made in units of a sector, a word line or a byte. Corresponding portions of the memory device of FIG. 1 to those of the conventional nonvolatile semiconductor memory device shown in FIG. 12 are denoted with the same reference numerals. Moreover, in an erasing operation, the same effects as those provided in the foregoing embodiment can be obtained even in a structure in which not every memory cell is erased at the same time but only memory cells to be programmed are erased. That is, the same effects as those provided in the foregoing embodiment can be obtained even in a nonvolatile semiconductor memory device in which data erasing is carried out in the units of word line, the units of byte or the units of sector. Furthermore, an erase setup instruction is written into the instruction port controller 2 (the status register 235 and the instruction register 237) (a step S8), and an erase instruction is subsequently written into the instruction port

Art Unit: 2133

controller 2 (a step S10). An erasing with respect to all the memory cells is executed in accordance with the writing of the erase instruction (a step S12). After a predetermined time period has passed, it is determined that the erasing of the memory cells is completed, and an erase verify instruction is written into the instruction port controller 2 (the status register 235 and the instruction register 237) (a step S14). In accordance with this erase verify instruction, an erase verify voltage is generated from the erase/program verification generator 9 and then transmitted via the X decoder 12 onto a selected word line in the memory cell array (a step S16). When a predetermined time period has passed (time T2), data reading is carried out (a step S18).

As per claims 7-9 and 16-18, Noguchi substantially teaches, in view of above rejections, the erasing operation of a nonvolatile semiconductor memory device. First, at the stage of initializing, a program high voltage V_{pp} is applied to the instruction port controller 2 to render the instruction port controller 2 operative (a step S2). Then, specific data (00H) is programmed for all bytes (data input/output is carried out in the units of byte and erasing is carried out also in the units of byte) (a step S4). This data programming is made in order to bring each memory cell into a write state and set the threshold voltage of each memory cell to be substantially equal. The Examiner would like to point out that this step is analogous to establishing a first test limit as stated in the present application. In addition, each counter is preset to a predetermined initial value (a step S6). This counter includes a counter for counting the number of time CUMTEW of the increase of an erase pulse width TEW, and a counter for counting the number of times PLSCNT by which erase pulses are generated. An address is set to 0. Then, an erase setup instruction is written into the instruction port controller 2 (the status register 235 and the instruction register 237) (a step S8), and an erase instruction is subsequently written into the

Art Unit: 2133

instruction port controller 2 (a step S10). An erasing with respect to all the memory cells is executed in accordance with the writing of the erase instruction (a step S12). After a predetermined time period has passed, it is determined that the erasing of the memory cells is completed, and an erase verify instruction is written into the instruction port controller 2 (the status register 235 and the instruction register 237) (a step S14). In accordance with this erase verify instruction, an erase verify voltage is generated from the erase/program verification generator 9 and then transmitted via the X decoder 12 onto a selected word line in the memory cell array (a step S16). When a predetermined time period has passed (time T2), data reading is carried out (a step S18). If the read data is an erased data, then the data is "1". If the read data is an unerased data, then the data is "0". A determination is made as to whether this data is in the erased state or not in accordance with its value (a step S20). If the data indicates the unerased state, then an erase pulse width to be applied to erase the data is incremented by a predetermined value, and this incremented erase pulse width information is stored in the TEW counter (a step S22). A determination is first made as to whether the erase pulse width stored in the TEW counter reaches a maximum limit value, and subsequently, a determination is made as to whether the number by which the erase pulses are applied reaches a predetermined value (64 times) (a step S24). When the erase pulse application number PLSCNT reaches the predetermined value (64 times), it is determined that no erasing is allowed for that memory cell any more, and an erase error is stored (a step S26). When the erase pulse application number PLSCNT does not reach the predetermined value in the step S24, the processing returns to the step S8, in which the writing and erasing operation by the erase setup instruction and the erase instruction is carried out.

The Examiner disagrees with the Applicant and maintains rejections with respect to amended claims 1-3, 5, 8, 12, 14 and 17 and original claims 4, 6, 7, 9, 11, 13, 15, 16 and 18. All arguments have been considered. It is the Examiner's conclusion that amended claims 1-3, 5, 8, 12, 14 and 17 and original claims 4, 6, 7, 9, 11, 13, 15, 16 and 18 are not patentably distinct or non-obvious over the prior art of record. See prior office action above.

Conclusion

THIS ACTION IS MADE FINAL. Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

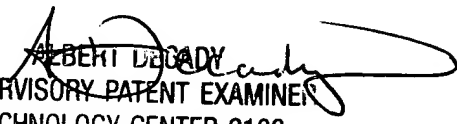
Art Unit: 2133

Any inquiries concerning this communication should be directed to the examiner, Mujtaba Chaudry who may be reached at 571-272-3817. The examiner may normally be reached Mon – Thur 6:30 am to 4:30 pm.

If attempts to reach the examiner by telephone are unsuccessful, please contact the examiner's supervisor, Albert DeCady at 571-272-3819.



Mujtaba Chaudry
Art Unit 2133
November 16, 2004



ALBERT DECADY
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